



Large-Scale Print-Manufacturing of Complex 3D Structures

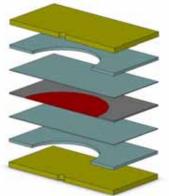
Arthur L. Chait CEO, EoPlex Inc. Feb. 10, 2010

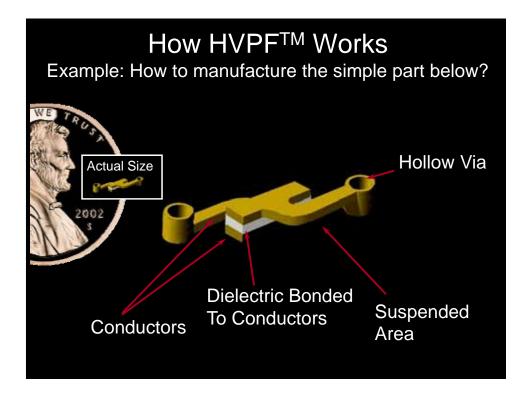


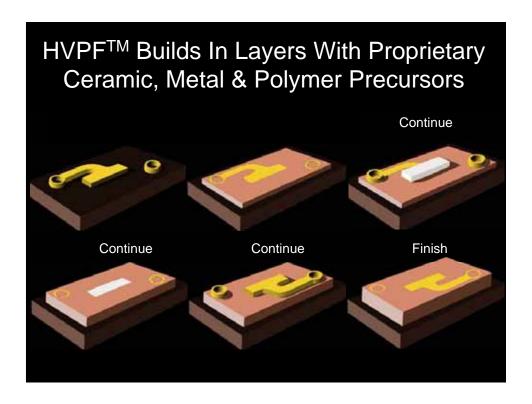
1

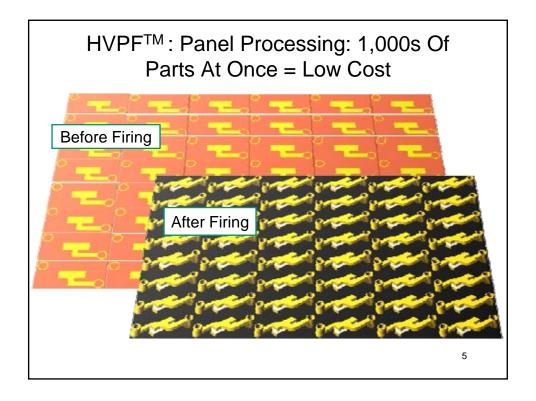
High Volume Print Forming (HVPF™)

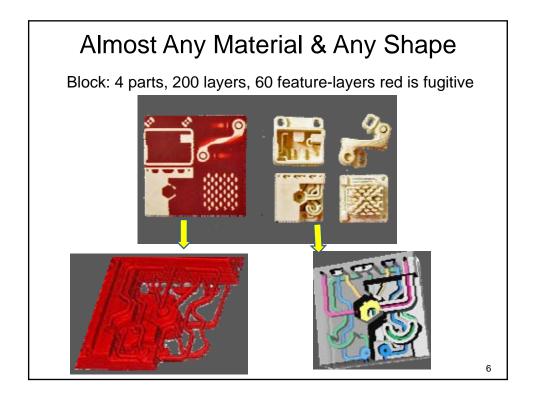
- Layered process, but NOT rapid prototyping
- Uses metals, ceramics & polymers
- Material combinations & metastructures
- Low cost and clean-technology
- Increased design freedom
- Produces thousands of parts at once











EoPlex Basic Design Rules

Device Dimensions

Min. length 1mm Max. length 200 mm

Feature Dimensions Minimums

Standard Process

High Aspect Ratio Features 200 μ Thick Planar Features 50 μ Extended Process 25 μ Feature Tolerance $\pm 0.5\%^*$

Layer Characteristics

Materials/layer (typical) 2 to 5 Typical layer thickness 5 μ to 500 μ Min. layer thickness 3 μ





7

EoPlex Current Catalog Of Materials

Ceramics

- Glass-ceramics
- Piezoelectric materials (PZT)
- Oxides: Alumina (Al₂O₃), silica (SiO₂), zirconia (Zr₂O₃)
- Custom low loss dielectrics

Metals

- Structural metals: Nickel alloys, stainless steel, iron
- · Conductors: Palladium, silver, gold, platinum

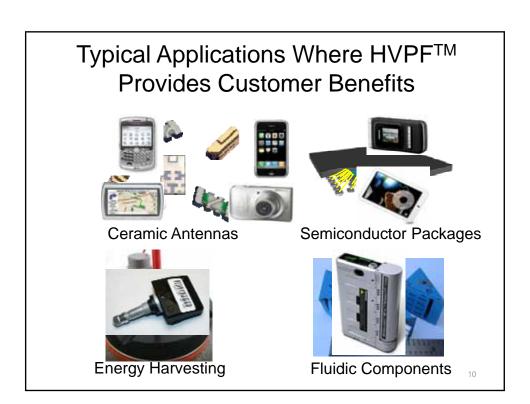
Polymers with and without fillers

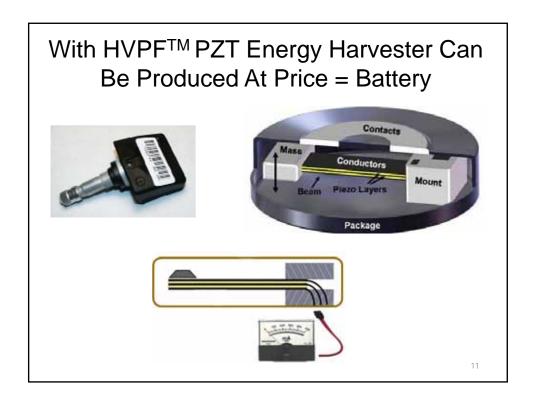
8

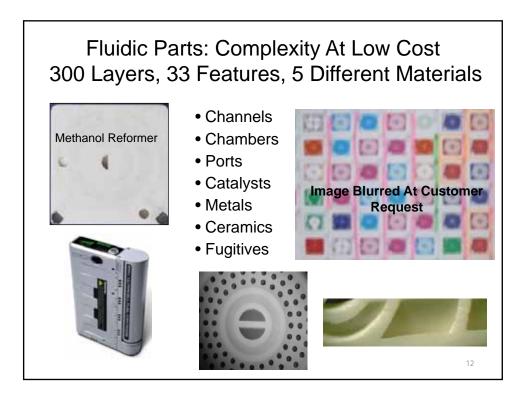
^{*} none less than 10μ

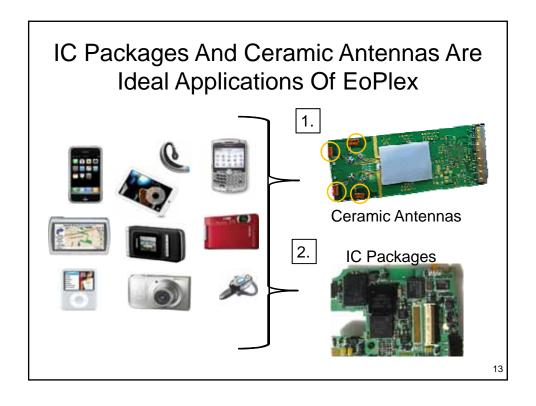
HVPF[™] FAB: Small, Low Cost & Easily Located Along Customer's Supply Chain

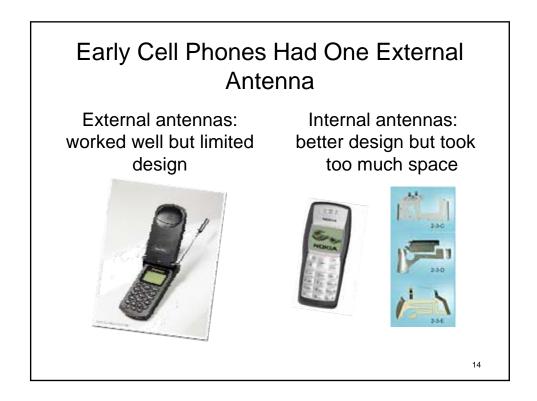


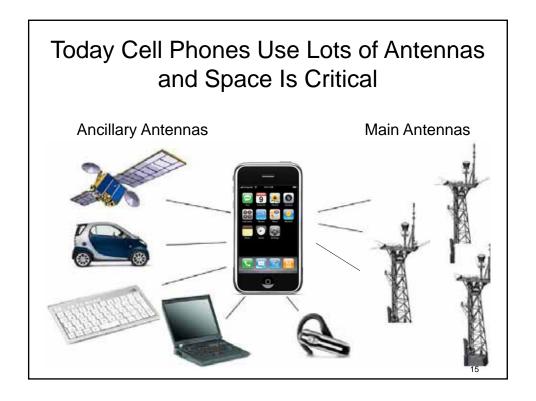


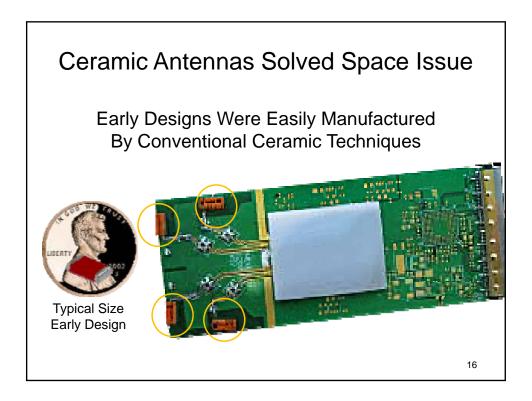














HVPF^{TM*} Was Identified By Antenna OEMs As A Process To Fill The Gap

| Process Features | Form-Fire & Metalize | Tape Process LTCC | EoPlex (HVPF™)* |
|------------------------|-------------------------|-------------------|-----------------|
| 3-D Design Flexibility | Limited 🔔 | Limited | High |
| Internal Connections | No 🙋 | Punched Vias | Unlimited |
| Internal Features | Very Limited | Yes | Yes |
| Materials Flexibility | High | Limited | Yes |
| Multiple Materials | Very | Limited | Yes |
| Metamaterials | No 🙋 | Very Limited | Yes |

^{*}High Volume Print Forming (HVPFTM)

18

HVPFTM Antennas Are Being Built With Better Performance In Smaller Package

Tech. Advantage

Advanced Designs

Materials Freedom

Internal Features

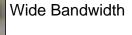
3-D Structures

Metastructures





Customer Benefit High Efficiency



Low Cost

Small Size

Multiple Antennas on One Chip



Metamaterials

A material that gains its properties from structure rather than directly from composition



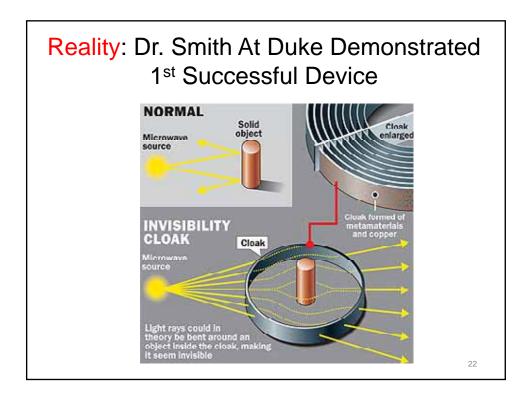




Mother of Pearl

20

Lots Of Interest In Using Metamaterials To Create Real Cloaking Devices Star Terk: Klingon Bird-Of-Prey Warship



HVPFTM Voxel Deposition* Can Produce Micron-Level Metastructures

Voxel is like a tiny Lego® block

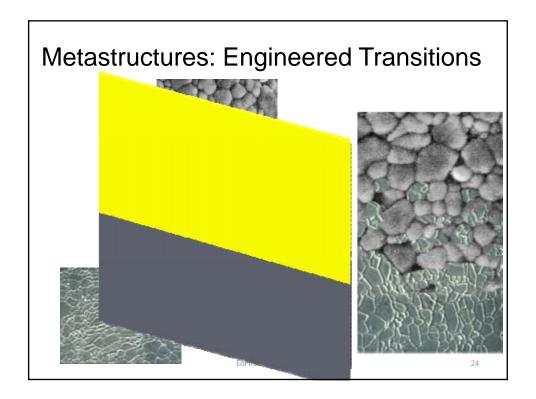


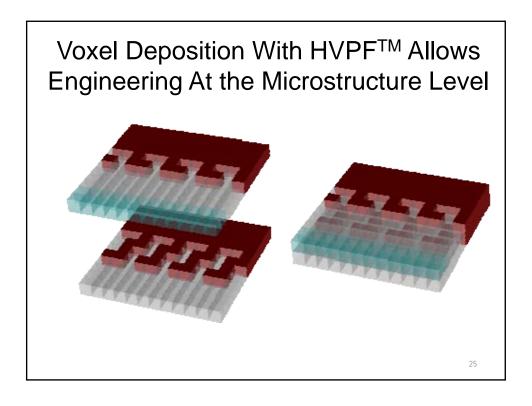


Lego ® Einstein

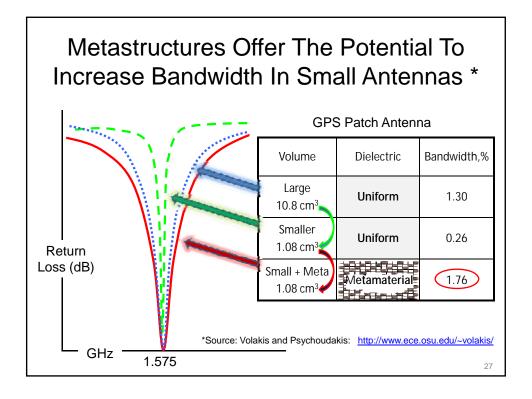
- HVPFTM builds in voxels* microbricks
- Voxels of different materials = metastructure
- · Several applications
- * Patent pending

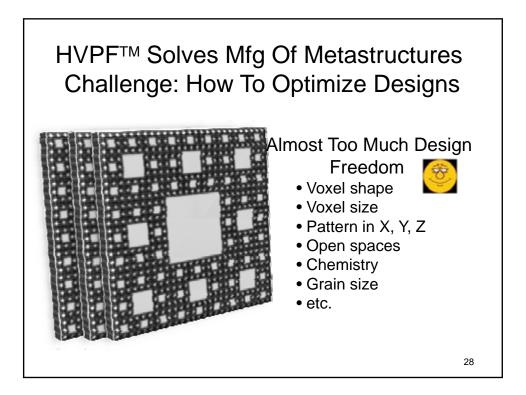
23

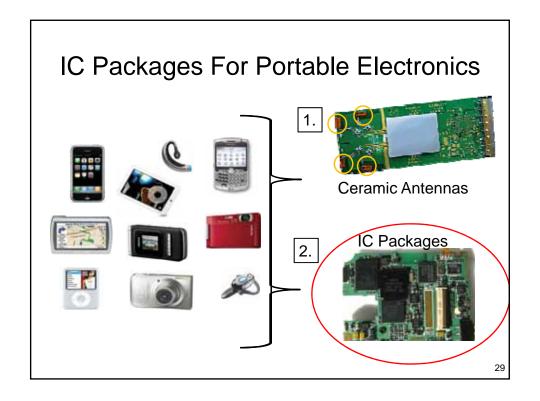


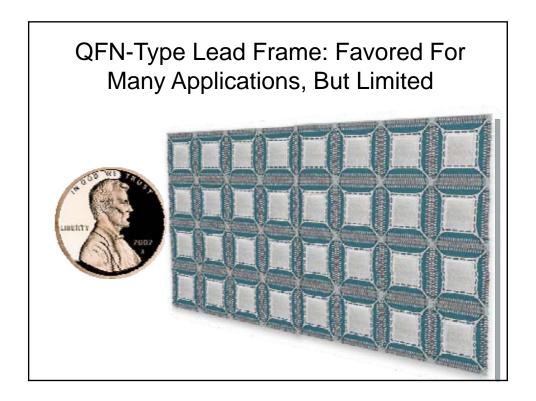


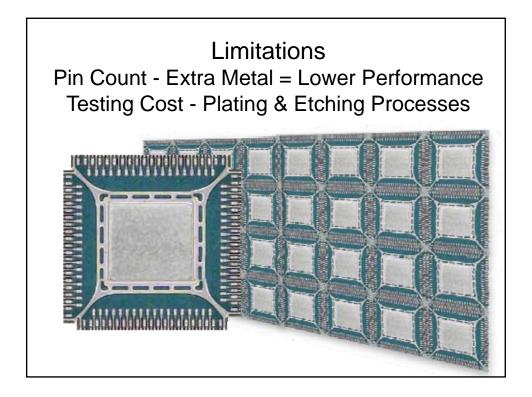


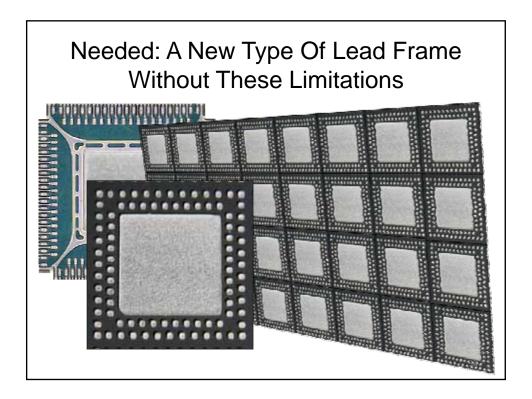


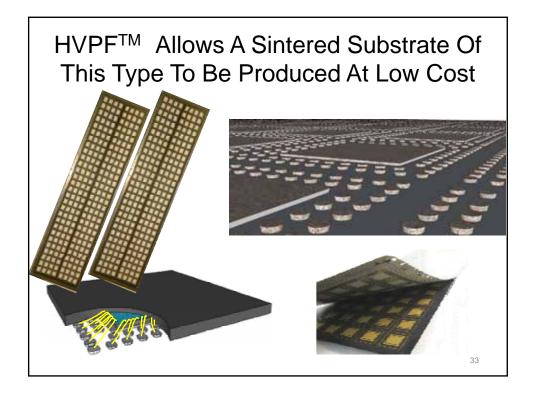












EoPlex New Package Substrate Will Be Introduced In Q2

- Low package volume and high lead count
- Min. metal necessary = min. inductance and capacitance
- Lead counts >500, pitch down to 300µ
- Testing and dicing cost reduced
- Lower cost package = lower device price
- Clean-tech process, no plating or etching

*Patent-Pending

www.cpmt.org/scv 17

34

Summary HVPFTM A Clean, Low Cost Way To Produce High Performance Parts



Clean-Tech **Process**



Lower Cost



Smaller Size & Better Designs Performance



Higher

35

